

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Assistant Commissioner for Patents, Alexandria, VA 22313, on November 7, 2005

(Date of Deposit)

Anthony P. Curtis, Ph.D., Reg. 46,193

Name of Applicant, Assignee or Registered Representative

Signature

Date of Signature



Our Case No. 9281-4140
Client Reference No.: CK US00016

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Akira Nakano et al.

Serial No.: 09/925,579

Filing Date: August 9, 2001

For: PLASMA PROCESSING APPARATUS
AND SYSTEM, PERFORMANCE
VALIDATION SYSTEM AND INSPECTION
METHOD THEREFOR

Examiner: Rudy Zervigon

Group Art Unit No.: 1763

REQUEST FOR CONTINUED EXAMINATION AND RESPONSE TO OFFICE ACTION OF JUNE 7, 2005

Mail Stop RCE
Commissioner for Patents
Washington, D.C. 22313 -1450

Dear Sir:

This is a Request for Continued Examination, and a Response to the Office Action dated June 7, 2005 in the above referenced application. Applicants respectfully request reconsideration, reexamination and allowance of claims 1 - 9 in view of the following amendments/remarks

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 5 of this paper.

11/10/2005 WABDELK1 00000039 231925 09925579 790.00 0P
01 FC:1801